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2814-
AF/GB

XA-9590

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masao SHINOZAKI et al.

S r i a l No.: 10/002,009

Group Art Unit: 2814

Filed: December 5, 2001

Examiner: S. Rao

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE

* * *

PETITION FOR EXTENSION OF TIME

BOX AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time now set for response be extended, retroactively, by two months. The required petition fee for a large entity is submitted herewith. If any further extension of time is required to avoid abandonment of this application, such extension is hereby requested. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 that may be required by this paper to Deposit Account No. 50-1165.

08/05/2003 EFLORES 00000085 10002009

01 FC:1252

410.00 OP

MWS:sjk

Miles & Stockbridge P.C.
1751 Pinnacle Drive
Suite 500
McLean, Virginia 22102-3833
(703) 903-9000

August 4, 2003

Respectfully submitted,

By: Nelson H. Shapiro
Nelson H. Shapiro
Reg. No. 17,095

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